

Envent Model 131S

Process Gas Chromatograph

The Model 131S Process Gas Chromatograph (GC) is a simple approach to energy measurement, created and designed for many different applications. Envent provides a Process Gas Chromatograph platform that is efficiently manufactured to ensure industry leading delivery, while providing a GC that allows for ease of serviceability.

Features

- High performance GC columns packed in our Envent GC Lab
- Reduced carrier usage due to efficient column design

Field-Serviceability

- Easy access Electronics Enclosure with single board technology
- Easy access GC Detector/Column Oven for easy GC valve diaphragm replacement and column change
- Typical downtime for diaphragm and column change: approx. 30 minutes
- No modules to maintain or un-planned downtime due to non-serviceability and high cost of competitor's module technology
- Returns ownership to the measurement technician rather than the GC manufacturer

Natural Gas Applications

- Energy Measurement
- Pipeline Monitoring
- Custody Transfer
- Biogas/Landfill
- Power Generation
- Turbine Control

Gas Processing Applications

- Cryogenic gas plant
- NGL/LPG (methanol ethanol)
- LNG
- Fractionation/ Hydrocarbon Purity
- Gas Sweetening
- Methanol in NGL
- Methanol in Natural Gas

Electronics

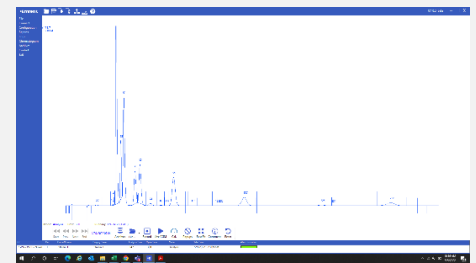
- Non-incendive electronic circuit design approved for Class I Division 1 electrical areas
- Includes all CPU, Memory, and I/O functions on a single board that operates together with the Envent Gas Chromatograph software
- Low-cost, simplified electronic troubleshooting approach

Software

- Archived custody stream chromatogram/chart storage
- Auto-storage of most recent calibration chromatogram/chart
- 18 months of archived analysis reports
- 6 months of archived calibration reports



131S Process Configuration



Envent Gas Chromatograph Software (GCS)



Easily Accessible GC Oven



1. Thermal Conductivity Detector (Max 2)
2. GC Valve (Max 6)
3. Column Dish
4. Sample Pre-Heat Coil (Max 4)

Specifications

Environmental Temperature	-20° to 60°C (-4° to 140°F) Quoted per application
Dimensions	Standard Configuration: 78" H x 24" W x 16" D (198cm H x 61cm W x 41cm D)
Mounting	Wall mount or floor mount
Enclosure	NEMA 4X
Electrical Classification	Class I, Division 1, Groups B, C, D
Power	120 +/- 10% VAC 50/60 Hz Standard 240 +/- 10% VAC 50/60 Hz Available
Power Consumption	Start up: 100 watts (does not include sample system electronics) Steady State: 60 - 80 watts nominal
Oven	Airless Heat Sink
GC Valves	Six-port and ten-port diaphragm chromatograph valves Thermal Conductivity Detector (TCD) Single or Dual TCD Capabilities (2-min application)
Stream Valves	Double Block and Bleed
Carrier Gas	UHP Helium (99.999%) or UHP Hydrogen (99.999%)
Actuation Gas	Helium, Nitrogen, Instrument Air (GC Valves/Stream Valves Regulated to 65 psig)
Detector	Thermal Conductivity Detector: Single or Dual TCD capabilities Advanced TCD allows for low ppm measurement
Peak Gating	Auto-Slope detection
Streams	Up to 4 Custody streams (plus auto-calibration stream)
Input/Output	Two (2) analog outputs Four (4) dry contact relay outputs Four (4) digital inputs Four (4) solenoid outputs
Communications	SIM 2251 Modbus mapping User Modbus mapping One (1) RS-232 serial communication port (Modbus capable) Two (2) RS-485 serial communication ports (Modbus capable) One (1) 1 Ethernet communication port RJ-45 (Modbus capable)
Measurement Calculations	Latest GPA 2145, GPA 2172, AGA 8, and ISO 6976 calculations

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